



Receipt
#4/cfr

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Serial No : Toru TATSUMI, ET AL.
Filed : 09/744,701
Title : January 29, 2001
Group Art Unit : **METHOD OF VAPOR PHASE GROWTH OF METAL OXIDE
DIELECTRIC FILM AND APPARATUS FOR VAPOR PHASE
GROWTH OF METAL OXIDE DIELECTRIC MATERIAL**
2812

April 25, 2001

Attn: Customer Corrections Division
Assistant Commissioner for Patents
Washington, D.C. 20231

REQUEST FOR CORRECTED FILING RECEIPT

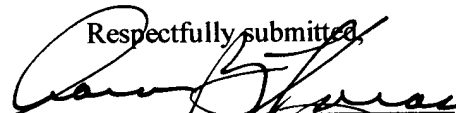
SIR:

We received the filing receipt on the above-referenced case, copy enclosed,
wherein the **TITLE** was incorrectly listed as: **VAPOR GROWTH METHOD FOR METAL OXIDE
DIELECTRIC FILM AND VAPOR GROWTH DEVICE FOR METAL OXIDE DIELECTRIC
MATERIAL**. Please change the same to read: **METHOD OF VAPOR PHASE GROWTH OF METAL
OXIDE DIELECTRIC FILM AND APPARATUS FOR VAPOR PHASE GROWTH OF METAL
OXIDE DIELECTRIC MATERIAL**. Also the **TOTAL CLAIMS** were incorrectly listed as: 1. Please
change the same to read: 71. Also the **INDEPENDENT CLAIMS** were incorrectly listed as: 1. Please
change the same to read: 13.

Any fee due with this paper, not fully
served by an enclosed check, may be
charged on deposit Acct. No. 08-1634

Helfgott & Karas, P.C.
60th Floor
Empire State Building
New York, New York 10118
Tel. (212) 643-5000
Docket No.: 18.281
SH:ejv:FILREC

Respectfully submitted,


Aaron B. Karas
Reg. No. 18,923

I HEREBY CERTIFY THAT THIS CORRESPONDENCE
IS BEING DEPOSITED WITH THE UNITED STATES
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20231, ON THE DATE INDICATED BELOW.

BY

DATE

April 25, 2001



APR 09 2001

UNITED STATES PATENT AND TRADEMARK OFFICE

COMMISSIONER FOR PATENTS
UNITED STATES PATENT AND TRADEMARK OFFICE
WASHINGTON, D.C. 20231
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| APPLICATION NUMBER | FILING DATE | GRP ART UNIT | FIL FEE REC'D | ATTY. DOCKET NO | DRAWINGS | TOT CLAIMS | IND CLAIMS |
|--------------------|-------------|--------------|---------------|-----------------|----------|------------|------------|
| 09/744,701 | 01/29/2001 | 2812 | 2578 | NECW 18.281 | 36 | 71 | 13 |

CONFIRMATION NO. 3273

FILING RECEIPT



OC000000005933950

Helfgott & Karas
60th Floor
Empire State Building
New York, NY 10118-0110

Date Mailed: 04/04/2001

Receipt is acknowledged of this nonprovisional Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please write to the Office of Initial Patent Examination's Customer Service Center. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the PTO processes the reply to the Notice, the PTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).

Applicant(s)

Toru Tatsumi, Tokyo, JAPAN;
Atsushi Yamashita, Tokyo, JAPAN;

Domestic Priority data as claimed by applicant

THIS APPLICATION IS A 371 OF PCT/JP99/04145 08/02/1999

Foreign Applications

JAPAN 219183/1998 08/03/1998
JAPAN 219184/1998 08/03/1998
JAPAN 219187/1998 08/03/1998

Projected Publication Date: N/A

Non-Publication Request: No

Early Publication Request: No

Title



~~Vapor growth method for metal oxide dielectric film and vapor growth device for metal oxide dielectric material~~

Preliminary Class

438

METHOD OF VAPOR PHASE GROWTH OF METAL OXIDE
DIELECTRIC FILM AND APPARATUS FOR VAPOR
PHASE GROWTH OF METAL OXIDE DIELECTRIC
MATERIAL

Data entry by : NGUYEN, SON

Team : OIPE

Date: 04/04/2001



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Bib Data Sheet

CONFIRMATION NO. 3273

| | | | | |
|------------------------------------|---|---------------------|-------------------------------|---|
| SERIAL NUMBER 09/744,701 | FILING DATE 01/29/2001 RULE | CLASS 438 | GROUP ART UNIT 2812 | ATTORNEY DOCKET NO. NECW 18.281 |
|------------------------------------|---|---------------------|-------------------------------|---|

APPLICANTS

Toru Tatsumi, Tokyo, JAPAN;
Atsushi Yamashita, Tokyo, JAPAN;

** CONTINUING DATA *****

THIS APPLICATION IS A 371 OF PCT/JP99/04145 08/02/1999

** FOREIGN APPLICATIONS *****

JAPAN 219183/1998 08/03/1998
JAPAN 219184/1998 08/03/1998
JAPAN 219187/1998 08/03/1998

IF REQUIRED, FOREIGN FILING LICENSE GRANTED

** 08/09/2001

| | | | | |
|--|----------------------------------|-----------------------------|---------------------------|---------------------------------|
| Foreign Priority claimed <input type="checkbox"/> yes <input type="checkbox"/> no | STATE OR COUNTRY JAPAN | SHEETS DRAWING 36 | TOTAL CLAIMS 71 | INDEPENDENT CLAIMS 13 |
| 35 USC 119 (a-d) conditions met <input type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance | | | | |
| Verified and Acknowledged | Examiner's Signature | Initials | | |

ADDRESS

Helfgott & Karas
60th Floor
Empire State Building
New York, NY 10118-0110

TITLE

Method of vapor phase growth of metal oxide dielectric film and apparatus for vapor phase growth of metal dielectric material

| | | |
|------------------------------------|---|--|
| FILING FEE RECEIVED 2578 | FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following: | <input type="checkbox"/> All Fees |
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